

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Youhei SAKAI

Serial No: 10/599,544

Filed: May 23, 2007

Confirmation No.: 1542

For: Silicon Casting Apparatus and Method of
Producing Silicon Ingot

Art Unit: 1793

Examiner: Diana J. Liao

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

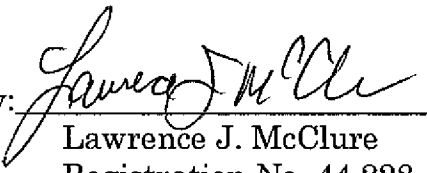
Dear Sir:

In response to the Restriction Requirement dated August 9, 2010, Applicant elects for prosecution Group I, claims 1-14 drawn to a silicon casting apparatus. Applicant also requests that since the nonelected dependent claims 15 to 17 depend from elected independent claim 1, the nonelected dependent claims 15 to 17 be rejoined if the elected claim 1 is found allowable.

If there are any fees due in connection with the filing of this response, please charge the fees to our Deposit Account No. 50-1314.

Respectfully submitted,
HOGAN LOVELLS US LLP

Date: September 8, 2010

By: 
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